·	Application No.	Applicant(s)	
Notice of Allowability	10/749,497	CHU ET AL.	
	Examiner	Art Unit	
	William C. Choi	2873	
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.31: 1. This communication is responsive to 2. The allowed claim(s) is/are 1-13.	ears on the cover sheet wi (OR REMAINS) CLOSED in) or other appropriate committed	ith the correspondence address in this application. If not included unication will be mailed in due cou	ırse. THIS
3. The drawings filed on are accepted by the Examine	er.		
 4. Acknowledgment is made of a claim for foreign priority unally all bloometons. a) All bloometons of the continuous of the continuous of the continuous of the priority documents have a continuous of the priority documents have a continuous of the certified copies of the priority documents of the certified copies of the priority documents of the certified copies of the certified copies of the priority documents. * Certified copies not received: 	e been received. e been received in Applicatio	on No	n from the
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	of this communication to file MENT of this application.	a reply complying with the requir	ements
5. A SUBSTITUTE OATH OR DECLARATION must be subminformal PATENT APPLICATION (PTO-152) which give			ICE OF
6. CORRECTED DRAWINGS (as "replacement sheets") mu (a) including changes required by the Notice of Draftsper 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR reach sheet. Replacement sheet(s) should be labeled as such in the state of the sheet.	son's Patent Drawing Review 's Amendment / Comment or 1.84(c)) should be written on the header according to 37 CF	r in the Office action of he drawings in the front (not the backers).	
7. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT			e the
Attachment(s)			
1. Notice of References Cited (PTO-892)	5. Notice of In	formal Patent Application (PTO-1	52)
2. \boxtimes Notice of Draftperson's Patent Drawing Review (PTO-948)		ummary (PTO-413), /Mail Date	
 3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/Paper No./Mail Date 1203 4. ☐ Examiner's Comment Regarding Requirement for Deposit 	08), 7. Examiner's	Amendment/Comment Statement of Reasons for Allowa	unoo
of Biological Material	9. ☐ Other	Statement of Reasons IOI Allowa	IICE
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Allowed Claims: 1-13.

REASONS FOR ALLOWANCE

Page 2

The following is an examiner's statement of reasons for allowance: none of the prior art either alone or in combination disclose or teach of the claimed combination of limitations to warrant a rejection under 35 USC 102 or 103.

Specifically, with respect to independent claim 1, none of the prior art alone or in combination disclose or teach of a method of operating a digital micromirror device comprising applying a reset voltage pulse to the micromirror and applying an offset voltage to the micromirror immediately after the reset voltage pulse as claimed, specifically comprising applying a damping pulse to the micromirror immediately after the offset voltage and reapplying the offset voltage to the micromirror, whereby the damping pulse reduces oscillation of the micromirror about a neutral position.

Specifically, with respect to independent claim 9, none of the prior art alone or in combination disclose or teach of a method of operating a digital micromirror device comprising applying a reset voltage pulse to the micromirror and applying an offset voltage to the micromirror immediately after the reset voltage pulse as claimed, specifically comprising applying a damping pulse to the micromirror immediately after the offset voltage and reapplying the offset voltage to the micromirror, whereby the damping pulse reduces oscillation of the micromirror about a neutral position and whose voltage is the same as the reset voltage.

CITATION OF RELEVANT PRIOR ART

The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. Gale, Jr. (U.S. 5,285,196) is being cited herein to show a method of operating a digital micromirror device comprising some of the steps of the claimed invention, but does not specifically disclose the applying a damping pulse to the micromirror immediately after the offset voltage and reapplying the offset voltage to the micromirror, whereby the damping pulse reduces oscillation of the micromirror about a neutral position.

CONCLUSION

Any inquiry concerning this communication or earlier communications from the examiner should be directed to William C. Choi whose telephone number is (571) 272-2324. The examiner can normally be reached on Monday-Friday from about 9:00 am to 6 pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Georgia Y. Epps can be reached on (571) 272-2328. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR.

Status information for unpublished applications is available through Private PAIR only.

Application/Control Number: 10/749,497

Art Unit: 2873

Page 4

For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

William Choi Patent Examiner Art Unit 2873 September 29, 2004

Georgia-Epps
Supervisory Patent Examiner
Technology Center 2800